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► **To cite this version:**

Soukalo Dembélé, Nadine Le Fort-Piat, Naresh Marturi, Brahim Tamadazte. Gluing free assembly of an advanced 3D structure using visual servoing.. 23rd Micromechanics and Microsystems Europe Workshop, MME'12., Sep 2012, Ilmenau, Germany. 6 p. hal-00799070

**HAL Id: hal-00799070**

**<https://hal.science/hal-00799070>**

Submitted on 11 Mar 2013

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# Gluing free assembly of an advanced 3D structure using visual servoing

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**Abstract**—The paper deals with robotic assembly of 5 parts by their U-grooves to achieve stables 3D MEMS, without any use of soldering effect. The parts and their grooves measure  $400 \mu\text{m} \times 400 \mu\text{m} \times 100 \mu\text{m} \pm 1.5 \mu\text{m}$  and  $100 \mu\text{m} \times 100 \mu\text{m} \times 100 \mu\text{m} \pm 1.5 \mu\text{m}$  leading to an assembly clearance ranging from  $-3$  and  $+3 \mu\text{m}$ . Two visual servo approaches are used simultaneously: 2D visual servo for gripping and release of parts and 3D visual servo for displacement of parts. The results of experiments are presented and analyzed.

**Keywords:** 3D microassembly, 3D MEMS, 2D visual servoing, 3D visual servoing

## I. INTRODUCTION

Since many years CMOS and specially MEMS technologies enable manufacturing of 2D structures and devices that have to be assembled into 3D microsystems such as are 3D photonic chips ([1], [2], [3], [4]), [5], [6]), 3D electronic chips using Through Silicon Vias ([7], [8], [9], [10]), 3D fluidic chips ([11], [12]), ball bearing, laser diodes. They increase the number of functions per unit volume and provide new functionalities paving the way for original solutions to known problems as well as for new applications.

Robotic assembly is the main solution to these manipulations in the 3D space, the other being self-assembly. It involves multiple degree-of-freedom robotic and gripping systems in conjunction with multifocal imaging systems leading to the natural use of visual servoing approaches. These are precise and robust, and then fit particularly the requirements of microscale manipulations. Many work have investigated 3D assembly from this point-of-view:

- insertion of peg into hole ([13], [14], [15], [16], [17], [18], [19], [20], [21]),
- assembly of 3D devices ([22], [23], [24], [25], [26]), [27], [28],
- ball arrangement ([29]).

In these papers, the modeling of the sequence of motions is rarely performed. But it facilitates understanding of assembly process and control of involved robots. Petri nets are generally used for this modelling ([30], [31], [32]).

The paper investigates modelling by Petri nets and control by dual visual servoing of the assembly of an advanced 3D device. The application is described (section II) and the corresponding motion modelling in (section III). Motion control based on both 2D visual servo (section IV) and 3D visual servo (section V) is presented and the results obtained are presented and discussed (section VI).

## II. APPLICATION

The application studied is the assembly of five parts by their U-grooves to get stable 3D structures, without any use of soldering effect (figure 1). The parts and their grooves measure  $400 \mu\text{m} \times 400 \mu\text{m} \times 100 \mu\text{m} \pm 1.5 \mu\text{m}$  and  $100 \mu\text{m} \times 100 \mu\text{m} \times 100 \mu\text{m} \pm 1.5 \mu\text{m}$  leading to an assembly clearance ranging from  $-3$  and  $+3 \mu\text{m}$ . It is a test device that highlights most of the problems of 3D assembly, notably the need of precision in the control of robot dedicated to the application.

The setup used is positioned inside a controlled environment

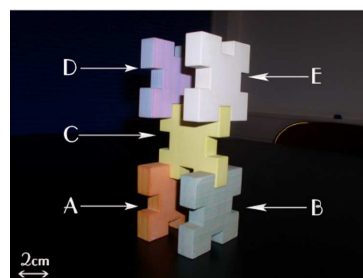


Fig. 1. Target 3D device at macroscale

on a vibration-free table (figure 2, table II). It comprises a 5 degree-of-freedom robotic systems distributed into two robots: a  $xy\alpha$  robot and a  $z\varphi$  robot. The former robot (positioning table) is equipped with a compliant support and enables positioning of parts in horizontal plane while the latter robot (manipulator) supports the gripper and enables vertical positioning and spatial orientation of parts. A 2-finger gripper with 4 degree-of-freedom (2 per finger) as described in ([33]) is used as handling system. Two optical microscopes positioned vertically (Leica MZ 16 A) and laterally at 45 (140 mm Navitar tube) enable visual feedback of the workfield. According to the references [34], [35], [36] and [37] both may be described by the linear perspective model whose parameters may be determined using a 2D calibration rig.

## III. MOTION MODELLING BY PETRI NETS

Modelling will meet the following policies:

- a task will be associated with a transition (possibly timed, represented by a rectangle),
- a state will be associated with a place (possibly with tokens, represented by a circle).

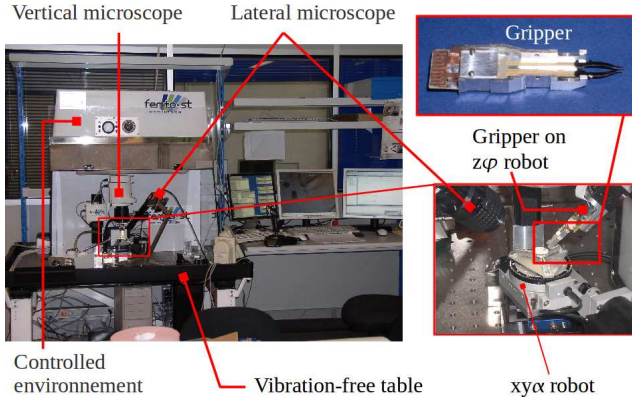


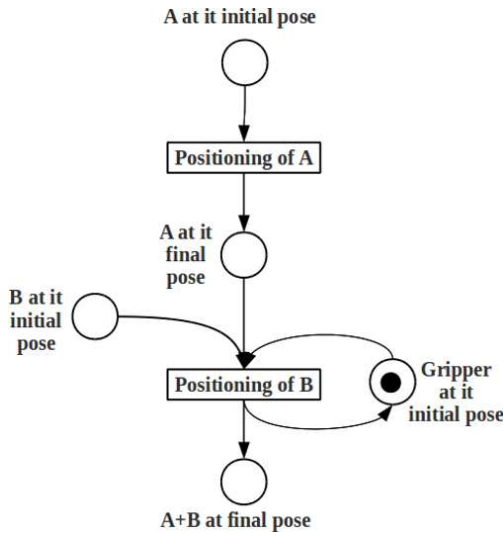
Fig. 2. Assembly setup

device	specifications
robot	linear/angular resolution: $0.05\mu\text{m} / 26\mu\text{rad}$
gripper	horizontal/vertical stroke: $320\mu\text{m} / 200\mu\text{m}$
vertical microscope	magnification/depth-of-field: $0.11\times / 3\text{ mm} - 0.035\text{ mm}$
lateral microscope	magnification/depth-of-field: $0.7\times / 1\text{ mm} - 0.1\text{ mm}$

TABLE I  
SPECIFICATIONS OF THE SETUP

The application considered is nothing but the generalization of the assembly of two parts, **A** and **B** for example. The problem consists in the positioning of **A** followed by the positioning of **B** into the vertical groove of **A**. Since initially all parts are positioned on the table, only the motions of **B** involve the gripper. Then, the assembly process may be described by the Petri net of figure 3.

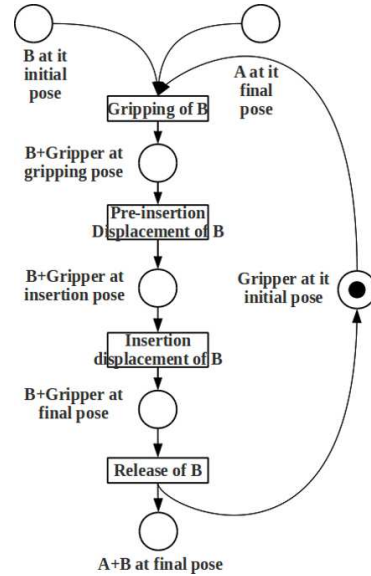
Positioning of **A** is a single task of displacement: dis-

Fig. 3. Petri net modelling assembly process of parts **A** and **B**.

placement of **A** from its initial position to its final position by means of  $xy\alpha$  table. In comparison, positioning of **B** is more complicated, it includes several tasks: gripping of

**B**, displacement of **B** to the insertion site (pre-insertion displacement of **B**), displacement of **B** to final site (insertion displacement of **B**), release of **B**. The corresponding model is represented figure 4.

Control of these tasks are strongly dependant on imag-

Fig. 4. Petri net modelling positioning of **B**.

ing system available and visual servoing used, the better these elements the better the performing. The following configurations are used for their relevances with respect to the problem: (vertical microscope, 2D visual servoing) for gripping and release tasks and (lateral microscope, 3D visual servoing) for displacement tasks. An interesting point of the setup is that the vertical microscope is fully controllable by computer (focus, magnification and acquisition) leading to the opportunity to overcome the limitation of the depth-of-field by performing a dynamic autofocus of the microscope. It also enable the performing of coarse to fine 2D visual servo by introducing the magnification  $\gamma$  in the control law (multiscale visual servo).

#### IV. GRIPPING USING MULTISCALE 2D VISUAL SERVO

Gripping of **B** includes the following tasks: zooming in, autofocusing, **B** detection, opening of the gripper fingers, part aligning and centering with respect to the gripper fingers, descent of the gripper down to the gripping plane, closing of the gripper to grip the part, zooming out, ascent of the gripper with the part (figure 5). Four systems are controlled in this task: gripper (opening, closing),  $z\phi$  robot (descent, ascent), microscope (zooming in, zooming out, autofocusing),  $xy\alpha$  robot (aligning and centering).

Let  $P_i, i = 1, 2, 3, 4$  be the four points delimiting the bonding box of a part. The tracking of these points are performed by the robust approach described in [38] and [39] which gives every time  $t$  and magnification  $\gamma$  the poses of the points in the image frame  $(u_i, v_i)^T$  that may be normalized using calibration parameters to  $s_i = (x_i, y_i)^T$ :

$$x_i = \frac{u_i - c_u}{f(\gamma)}, \quad y_i = \frac{v_i - c_v}{f(\gamma)} \quad (1)$$



$$s_B^{**} = \begin{pmatrix} {}^F t_{B^{**}} \\ 0 \end{pmatrix} \quad (12)$$

They are obtained by learning or directly from the CAD model.

Each task is performed by regulating to zero the error between current pose and desired pose.

Displacement of **A** involves the control the  $xy\alpha$  table as:

$$\begin{pmatrix} v_x \\ v_y \\ \omega_\alpha \end{pmatrix}_F = -\lambda \begin{pmatrix} {}^F t_x - {}^F t_{x^*} \\ {}^F t_y - {}^F t_{y^*} \\ {}^F \mathbf{R}_A \theta u_\alpha \end{pmatrix} \quad (13)$$

Pre-insertion displacement of **B** involves the control of the  $xy\alpha$  table as:

$$\begin{pmatrix} v_x \\ v_y \\ \omega_\alpha \end{pmatrix}_F = -\lambda \begin{pmatrix} {}^F t_x - {}^F t_{x^*} \\ {}^F t_y - {}^F t_{y^*} \\ {}^F \mathbf{R}_B \theta u_\alpha \end{pmatrix} \quad (14)$$

Insertion displacement of **B** involves the control of the  $z\phi$  manipulator as:

$$\begin{pmatrix} v_z \\ \omega_\phi \end{pmatrix}_F = -\lambda \begin{pmatrix} {}^F t_z - {}^F t_{z^{**}} \\ {}^F \mathbf{R}_B \theta u_\phi \end{pmatrix} \quad (15)$$

The gain  $\lambda$  is defined as described in equation 4.

## VI. RESULTS AND DISCUSSIONS

Figures 7 and 8 show some snapshots taken during the gripping. Evolution of gripping error is represented figures 9

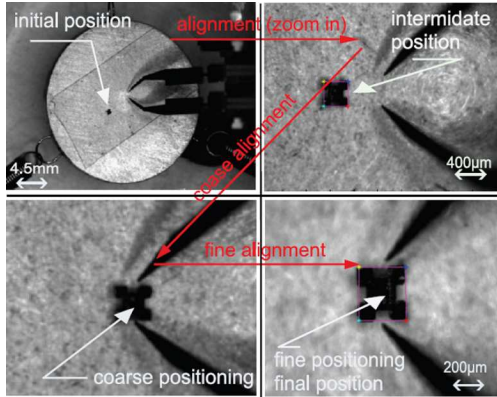


Fig. 7. Some shots of the workfield during the gripping: aligning, centering, zooming-in basic tasks

and 10 for the  $xy\alpha$  robot: the final values are  $2 \mu\text{m}$  and  $7 \times 10^{-3}$  radian for position and orientation respectively. Figure 11 shows some snapshots taken during the displacements. Evolution of displacement error is represented figures 12 and 13 for  $xy\alpha$  robot and  $z\phi$  robot respectively: the final values are  $4 \mu\text{m}$  and  $0.4 \times 10^{-3}$  radian respectively. Precision of 2D visual servo is better than that of 3D visual servo, in accordance with theory:  $2 \mu\text{m}$  against  $4 \mu\text{m}$ .

Figure 14 shows some SEM (scanning electron microscope) images of the final assembly. The obtained mechanical play is about  $3 \mu\text{m}$  showing the relevance of tracking to deliver high quality pose measurement and control to compute precise laws, compatible with microassembly requirements. The assembly is performed many times: the success and

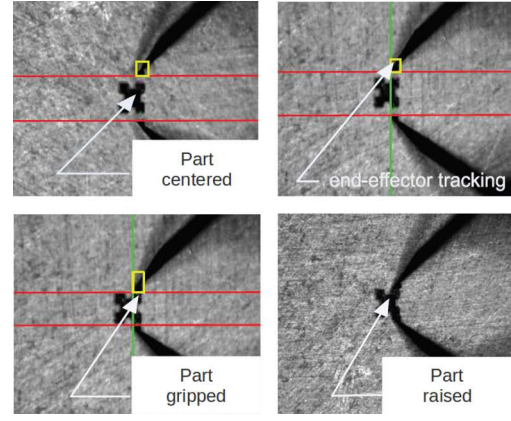


Fig. 8. Some shots of the workfield during part gripping: final result

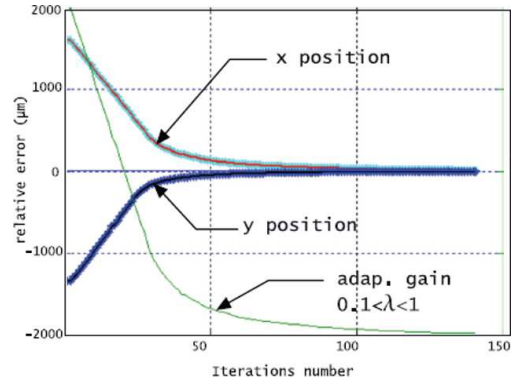


Fig. 9. Evolution of gripping error: position

failure ratios are 72 % and 28% respectively, the cycle time is about 40 s. These performances show the relevance of visual servo approaches to 3D microassembly and allow to consider their application to industrial cases. The sources of failure are:

- 17% for occlusions: occlusions of part by gripper cause the failure of part tracking,
- 22% for control error: controls are not precise enough to avoid the failure of tasks,
- 24% for capillary force: hydrometry of the scene is high enough to prevent release of part,

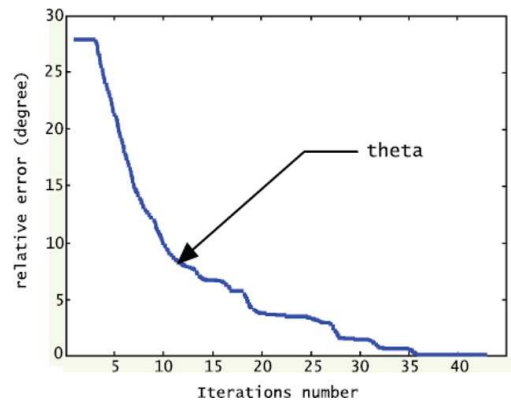


Fig. 10. Evolution of gripping error: orientation

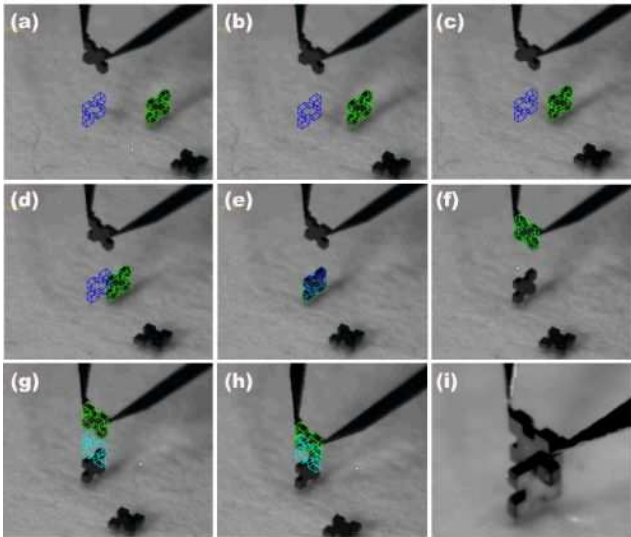


Fig. 11. Some shots of workfield during part displacements

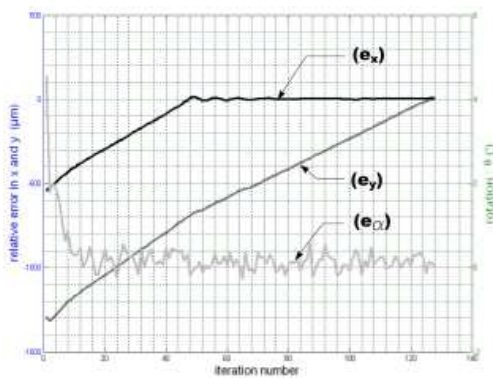


Fig. 12. Evolution of displacement error: xy robot

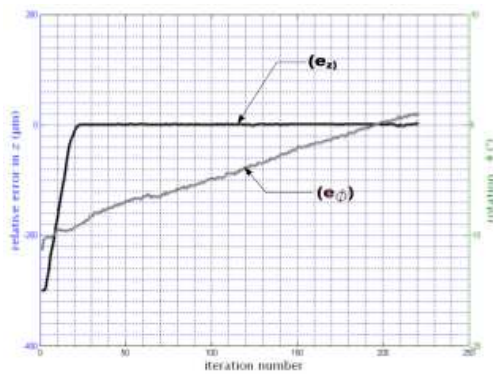


Fig. 13. Evolution of displacement error: z robot

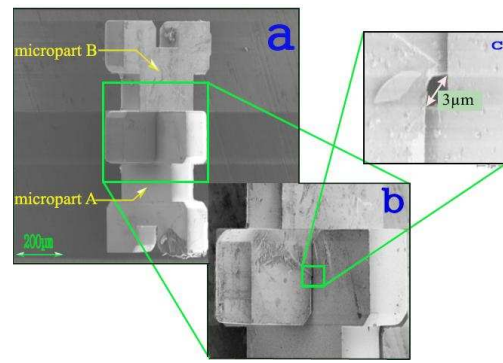


Fig. 14. Some images of the assembled structure from a scanning electron microscope

- 37% for electrostatic force: presence of electric charges on both parts and fingers cause the formers to move so uncontrolled.

Improvement of the success rate requires reduction of electrostatic and capillary forces, that may be obtained by efficient control of environment and functionalization of gripper fingers. Figure 15 shows some images of the final assembly of 5 parts and some steps: a right and stable structure is obtained without any use of soldering effect.

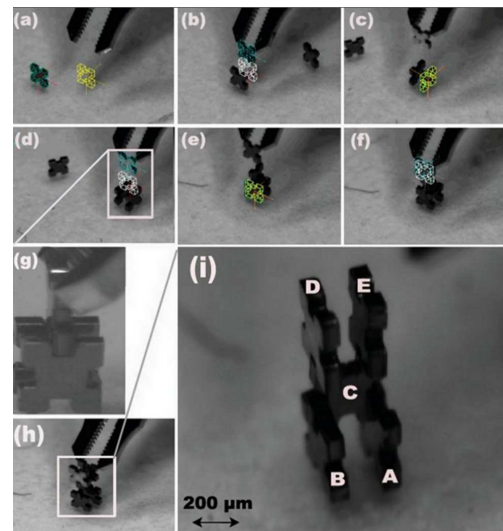


Fig. 15. Assembly of five parts on three levels.

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